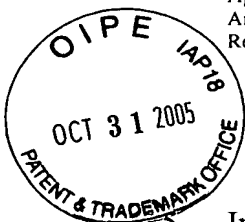


*172*

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Gotkis et al.

Application No: 10/674,373

Filed: September 29, 2003

For: APPARATUS AND METHOD FOR  
CONTROLLING FILM THICKNESS IN A  
CHEMICAL MECHANICAL PLANARIZATION  
SYSTEM

) Docket No: LAM2P445

) Group Art Unit: 3723

) Examiner: Rachuba, Maurina T.

) Date: July 28, 2005

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being  
deposited with the United States Postal Service as  
First Class Mail to: Commissioner of Patents,  
P.O. Box 1450, Alexandria, VA 22313-1450 on  
October 28, 2005.

Signed: \_\_\_\_\_

*Kay Harlow*  
Kay Harlow

AMENDMENT

Mail Stop: Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This Amendment is submitted in response to the Office Action dated July 28, 2005, within the three-month period for reply extending to October 28, 2005. Please enter the following amendments and remarks.

**Amendments to the Specification** are reflected on page 2 of this Amendment.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this Amendment.

**Remarks/Arguments** begin on page 10 of this Amendment.